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as set forth, and this application is intended to cover modifications and changes as may come within the scope of the following claims.

What is claimed is:

1. A susceptor for a vapor-phase growth apparatus comprising at least one through hole passing through a rear side

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at an outer peripheral portion of a wafer pocket which is formed as a concave shape in order to mount said wafer.

2. The susceptor of claim 1, wherein the at least one through hole is shaped as a groove and a plurality thereof is provided on a periphery.

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